

Notice of References Cited	Application/Control No. 10/797,867		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Monica Lewis		Art Unit 2822	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,376,986	04-2002	Takagi et al.	313/582
	B	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N	JP 2000-011894	01-2000	Japan	Kuni et al.	H01J 11/02
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NON-PATENT DOCUMENTS

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